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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Shyue-Ming JANG et al. Confirmation No: 1807  
Appl. No. : 10/660,715  
Filed : September 12, 2003  
Title : APPARATUS AND PROCESS FOR VACUUM  
SUBLIMATION  
  
TC/A.U. : 4116  
Examiner : B.M. Martinez  
  
Docket No.: : JANG3005/REF  
Customer No: : 23364

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This is in response to the Official Action of November 29, 2007, in connection with the above identified application. The period for response to this Official Action is set to expire on February 29, 2008. This response is timely filed.

Please amend the above-identified application as follows:

Amendments to the specification begin on page 2 of this paper.

Amendments to the claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks begin on page 9 of this paper.